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SERIAL NO.: Not yet known  
FILED: Herewith  
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#### AMENDMENTS TO THE SPECIFICATION

##### In the Specification:

Please replace the paragraph beginning on page 1 line 6 and ending on page 1, line 10, with the following paragraph:

##### --CROSS-REFERENCE TO RELATED APPLICATIONS

This application is a National Phase Application of PCT International Application No. PCT/IL2003/000455, International Filing Date June 1, 2003, claiming priority of Israel Patent Application Serial No. 150056, filed June 5, 2002, entitled "Low Pressure Chamber for Scanning Electron Microscopy in a Wet Environment". --